

Notice of References Cited		Application/Control No. 09/656,709	Applicant(s)/Patent Under Reexamination PARK ET AL.	
		Examiner Kim-Kwok CHU	Art Unit 2653	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,370,090	04-2002	Verbakel et al.	369/30.04
	B	US-6,205,112	03-2001	Weidner	369/275.3
	C	US-6,031,808	02-2000	Ueno	369/111
	D	US-5,835,589	11-1998	Nakashima	369/275.2
	E	US-5,812,519	09-1998	Kawamura et al.	369/275.2
	F	US-5,864,785- ^{5684 785}	11-1997	Itami et al.	369/275.2
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	O					
	P					
	Q					
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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